



[52433/858]

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Inventor : Masashi NAKABAYASHI et al.  
Application No. : 10/589,680  
Filed : August 16, 2006  
For : SILICON CARBIDE SINGLE CRYSTAL, SILICON  
CARBIDE SINGLE CRYSTAL WAFER, AND  
METHOD OF PRODUCTION OF SAME  
Examiner : LANGMAN, JONATHAN C  
Art Unit : 1794  
Confirmation No. : 9917

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on April 21, 2010

Signature: Katy Chan-Parsons  
Katy Chan-Parsons

**AMENDMENT UNDER 37 C.F.R. §1.114**

SIR:

In response to the Office Action mailed on December 7, 2009. Applicants respectfully request entry of the following amendments and remarks into the file of the above-identified application. Applicants submit concurrently herewith 1) a Request for Continued Examination (RCE); and 2) a Petition for Extension of Time.

**Amendments to the Claims** are reflected in the Listing of Claims which begins on page 2 of this paper.

**Remarks** begin on page 6 of this paper.